

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Karl-Heinz Schuster

Application No.: 10/596,626

Confirmation No.: 8534

Filed: June 19, 2006

Art Unit: 2873

For: MICROLITHOGRAPHY PROJECTION
OBJECTIVE WITH CRYSTAL LENS

Examiner: E. A. Lester

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 17, 2008, the shortened statutory response to which is due December 17, 2008, please consider the following remarks:

Remarks/Arguments begin on page 2 of this paper